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<input type="checkbox"/>	L5	L3 and ink.ab.	1414
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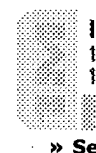
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<u>L6</u>	ink with (nanowire\$1 or nanotube\$1 or SWNT or MWNT or CNT)	176	<u>L6</u>
<u>L5</u>	(liquid adj carrier) with (nanowire\$1 or nanotube\$1 or SWNT or MWNT or CNT)	17	<u>L5</u>
<u>L4</u>	L3 and ((ink or ink-jet) and nano\$.ab.	7	<u>L4</u>
<u>L3</u>	L2 and (aspect adj ratio)	628	<u>L3</u>
<u>L2</u>	L1 and (ink adj jet)	4578	<u>L2</u>
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**1 Super-fine ink-jet printing for nanotechnology**
*Murata, K.;*

MEMS, NANO and Smart Systems, 2003. Proceedings. International Conference on , 20-23 July 2003

Pages:346 - 349

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**2 Fine-line conductor manufacturing using drop-on demand PZT printing technology**
*Szczzech, J.B.; Megaridis, C.M.; Gamota, D.R.; Jie Zhang;*

Electronics Packaging Manufacturing, IEEE Transactions on [see also Component Packaging and Manufacturing Technology, Part C: Manufacturing, IEEE Transactions on] , Volume: 25 , Issue: 1 , Jan. 2002

Pages:26 - 33

[\[Abstract\]](#)    [\[PDF Full-Text \(430 KB\)\]](#)    **IEEE JNL**
**3 Printing techniques in organic based optoelectronics**
*Jabbour, G.E.;*

 Semiconductor Device Research Symposium, 2001 International , 5-7 Dec. 2001  
 Pages:344

[\[Abstract\]](#)    [\[PDF Full-Text \(21 KB\)\]](#)    **IEEE CNF**
**4 Multi-scale analysis and design of nano imprint process**
*Jae Hyun Kim; Jung Yup Kim; Byung Ik Choi;*

Nanotechnology, 2003. IEEE-NANO 2003. 2003 Third IEEE Conference on , Volume: 1 , 12-14 Aug. 2003

Pages:263 - 266 vol.2

[\[Abstract\]](#)   [\[PDF Full-Text \(542 KB\)\]](#)   IEEE CNF

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**5 Micropatterning of micro/nanospheres on PDMS by using layer-by-layer self-assembly**

*Hua Ai; Lvov, Y.M.; Mills, D.K.; Jones, S.A.;*

Microtechnologies in Medicine & Biology 2nd Annual International IEEE-EMB S  
Topic Conference on , 2-4 May 2002

Pages:144 - 147

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